



SE-US045044

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Kazuaki SAKURADA : Patent Art Unit: 2871  
Serial No.: 10/796,276 :  
Filed: March 10, 2004 :  
For: APPARATUS AND METHOD FOR :  
FABRICATING FUNCTIONAL FILM :

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner of Patents  
Washington, DC 20231

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant brings the attached references to the Examiner's attention and requests that they be considered and made of record in this application. Also attached is a completed PTO-1449 form.

*No fee is believed to be due for this Information Disclosure Statement.* However, if a first Office Action on the merits was mailed before the filing date of this Information Disclosure Statement, the Commissioner is authorized to charge the fee set forth in 37 CFR § 1.17(p) to Deposit Account No. 50-1836. A duplicate copy of this Statement is enclosed for that purpose.

Since this application was filed after June 30, 2003, the U.S. Patent and Trademark Office waives the requirement under 37 C.F.R. 1.98 (a) (2) (i) for submitting a copy of each cited U.S. Patent and each U.S. Patent Application Publication.

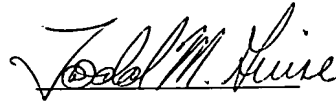
A copy of Korean Office Action of the corresponding Korean Patent Application No. 2003-74051 is attached hereto.

Korean Patent Application No. 2003-74051 is believed to be equivalent to US Patent Application Publication Nos. 2003-223030 and 2005-248715, which are cited as a translation.

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Prompt examination on the merits is respectfully requested.

Respectfully submitted,



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